

FIG. 1 (PRIOR ART)

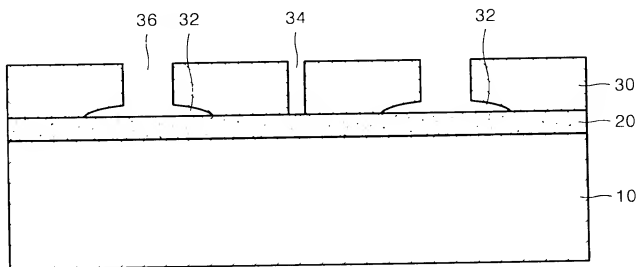


FIG. 2

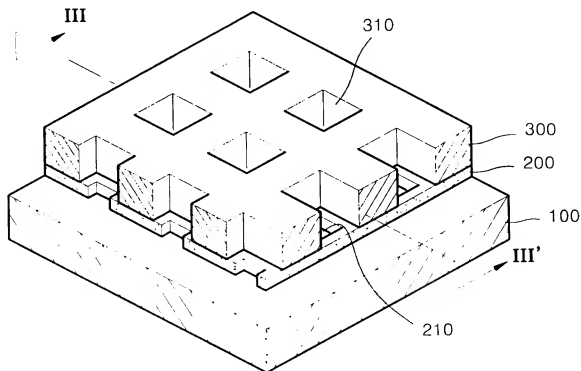


FIG. 3

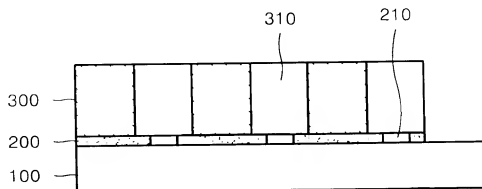


FIG. 4A

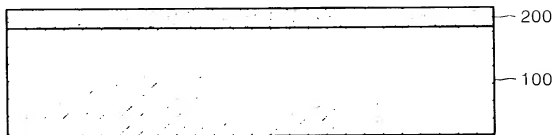


FIG. 4B

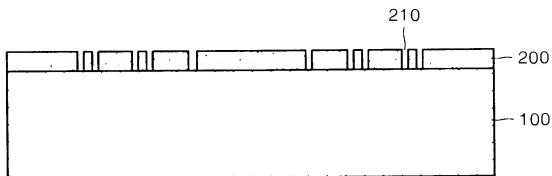


FIG. 4C

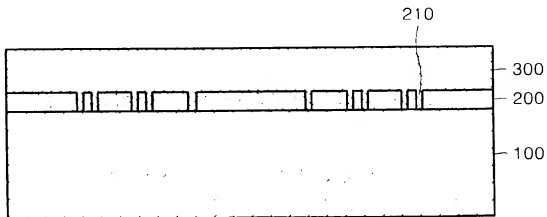


FIG. 4D

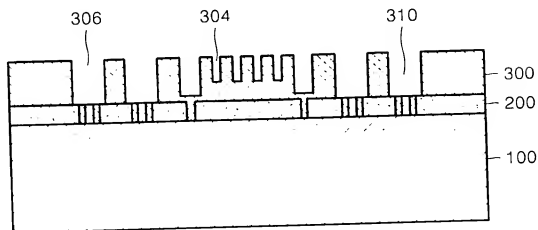


FIG. 4E

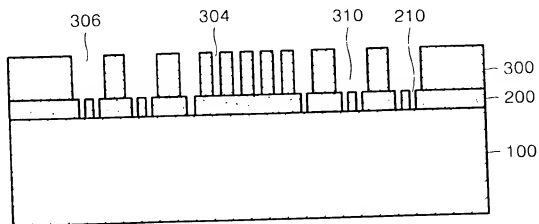
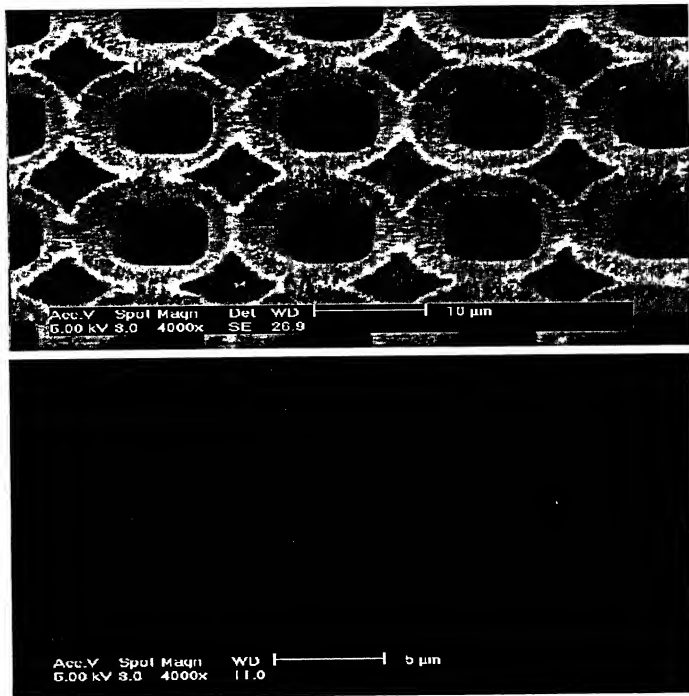


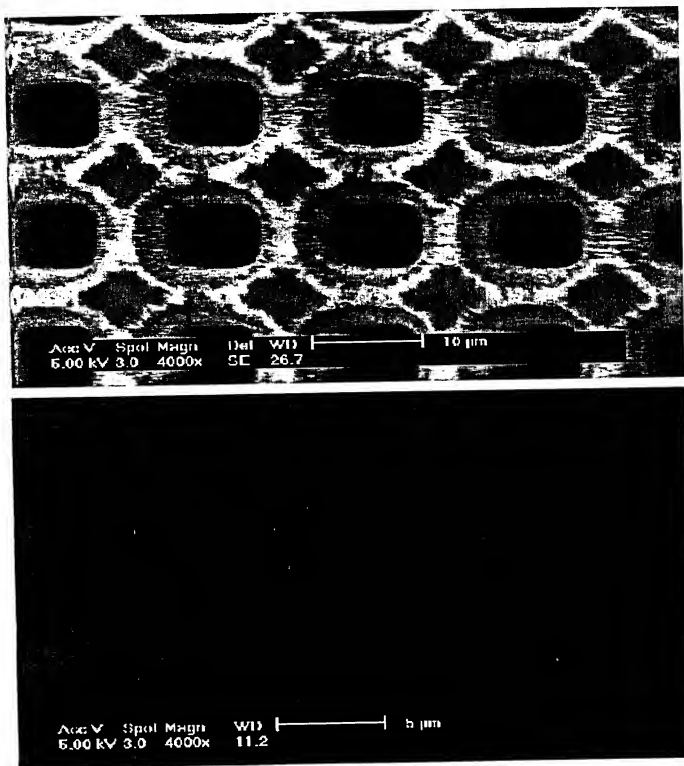
FIG. 5 (PRIOR ART)



APPN. FILING DATE: DECEMBER 26, 2001
TITLE: METHOD OF REDUCING NOTCHING DURING
REACTIVE ION ETCHING
INVENTOR(S): BYEUNG-LEUL LEE ET AL.
APPLICATION SERIAL NO: 030681-341

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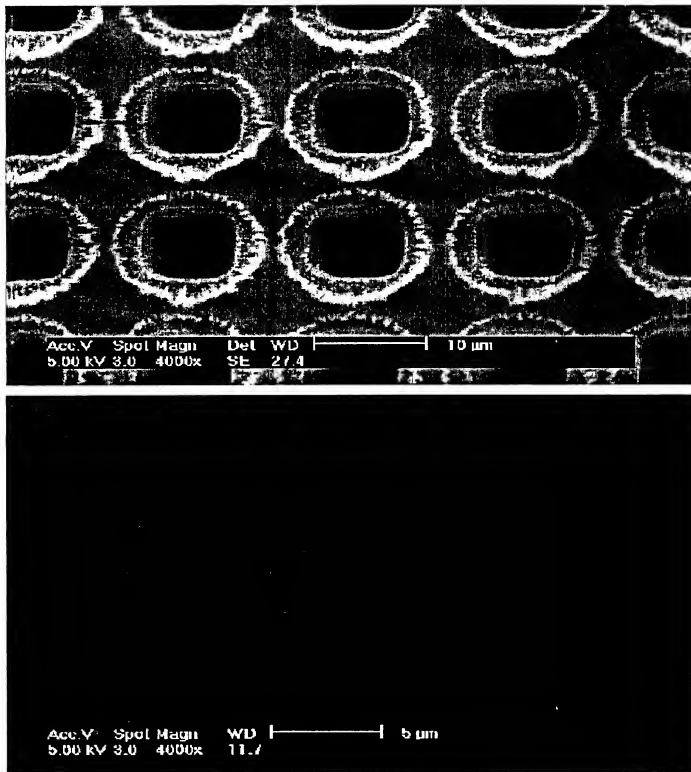
FIG. 6



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INVENTOR(S): BYEUNG-HUT LEE ET AL.
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FIG. 7



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